



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji NAKAMURA et al.

Application No. 09/680,054

Filed: October 5, 2000

For: SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR SUBSTRATE,  
AND MANUFACTURE METHOD

)  
) Group Art Unit: 2823  
) Examiner: Brook Kebede  
) Confirmation No. 7323  
) Date: March 3, 2004  
)  
)

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: Deborah Movahhedi

AMENDMENT

Mail Stop **BOX AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 3, 2003, please amend the above identified application as follows.

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